Electronic Acknowledgement Receipt						
EFS ID:	2459528					
Application Number:	10828596					
International Application Number:						
Confirmation Number:	5520					
Title of Invention:	Methods of forming metal thin films, lanthanum oxide films, and high dielectric films for semiconductor devices using atomic layer deposition					
First Named Inventor/Applicant Name:	Ki-yeon Park					
Customer Number:	20792					
Filer:	Shawna Cannon Lemon/Laneisha Hayes					
Filer Authorized By:	Shawna Cannon Lemon					
Attorney Docket Number:	5649-1286					
Receipt Date:	13-NOV-2007					
Filing Date:	21-APR-2004					
Time Stamp:	13:41:55					
Application Type:	Utility under 35 USC 111(a)					
Payment information:						
Submitted with Payment	no					

File Listing:									
Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)				
1	Amendment After Final	56491286AmendFinal11130 7.pdf	54692	no	1				
			8b08e450d3aad6461573bb3e87d22ca3 5c8aa69f						
Warnings:									

Information:

2	Claims	56491286Claims111307.pdf	650120	no	10				
			c2d2853e9u046892597e962260253167 69e6847d						
Warnings:									
Information:									
3	Applicant Arguments/Remarks Made in an Amendment	56491286Remarks111307.p df	194472	no	3				
			fe0b0ecda50bb24be3b521d832e12745 43207ee9						
Warnings									

Information:

Total Files Size (in bytes):

899284

This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.

## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

## National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.

## New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the international Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.